



Attorney/Docket No. 2003-0125 / 24061.49  
Customer No. 42717

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Chih-Wei Hsu, et al.	§	Docket No.:	24061.49
		§		(TSMC2003-0125)
Serial No.:	10/791,930	§		
		§	Examiner:	TBD
Filed:	March 3, 2004	§		
		§	Art Unit:	2121
Entitled:	System and Method for Process	§		
	Contamination Prevention for	§		
	Semiconductor Manufacturing	§		

**INFORMATION DISCLOSURE STATEMENT**

Commissioner For Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

In compliance with the duty of disclosure under 37 CFR §1.56, and in accordance with the practice under 37 CFR §1.97 and §1.98, the Examiner's attention is directed to the documents listed on the enclosed modified Form PTO-1449. No inference should be made that the cited references are in fact material, are in fact prior art, or that no better art exists. The cited patents are listed in numerical and alphabetical order and are not listed in any order based on their pertinence.

The above-identified application was filed after June 30, 2003. Therefore, pursuant to the waiver of the requirement under 37 CFR 1.98 (a)(2)(i) as stated in a Pre-OG Notice dated July 11, 2003, copies of the U.S. patents listed on the enclosed modified Form PTO-1449 are not being provided.

This Information Disclosure Statement is being filed within three months of the United States filing date or before the mailing date of a first Office Action on the merits. No certification or fee is required (37 CFR §1.97(b)). The Commissioner is hereby authorized to charge any additional fees which may be required or credit any overpayment to Deposit Account 08-1394.

It is respectfully requested that the above information be considered by the Examiner and that a copy of the enclosed Form PTO-1449 be returned indicating that such information has been considered.

Respectfully submitted,

*Timothy F. Bliss*

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Date: June 10, 2004

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**Certificate of Mailing**

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail in an envelope addressed to Commissioner For Patents, Washington, D.C. 20231 on the date indicated below:

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*6-11-04*  
Date

In place of PTO-1449 Form		U. S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		Complete if Known	
JUN 16 2004 <b>INFORMATION DISCLOSURE STATEMENT BY APPLICANT</b> (use as many sheets as necessary)				Application Number	10/791,930
				Filing Date	March 3, 2004
				Applicant(s)	Chih-Wei Hsu, et al.
				Art Unit	2121
				Examiner Name	TBD
				Attorney Docket Number	24061.49 (TSMC2003-0125)
SHEET	1	OF	1		

U. S. PATENT DOCUMENTS				
Examiner's Initials	Cite No.	Document Number	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document
	AA	6,349,237	02-19-2002	Koren, et al.
	AB	6,363,294	03-26-2002	Coronel, et al.
	AC	6,408,220	06-18-2002	Nulman
	AD	6,415,193	07-02-2002	Betawar, et al.
	AE	6,473,664	10-29-2002	Lee, et al.
	AF	6,505,090	01-07-2003	Harakawa
	AG	6,546,308	04-08-2003	Takagi, et al.
	AH	US 2003/0069660 A1	04-10-2003	Jun, et al.

FOREIGN PATENT DOCUMENTS					
Examiner's Initials	Cite No.	Foreign Patent Document (Country Code - Number - Kind)	Publication Date MM-DD-YYYY	Patentee or Applicant of Cited Document	Translation Y/N

OTHER PRIOR ART		
Examiner's Initials	Cite No.	Include name of the author (in CAPITAL LETTERS), title of the article, title of the item, date, page(s), volume-issue number(s), publisher, city/country where published

Examiner Signature		Date Considered	
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EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include a copy of this form with next communication to applicant.